

10/577043

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Application Data Sheet

Application Information

Application Type:: Regular
Subject Matter:: Utility
Suggested Group Art Unit:: N/A
CD-ROM or CD-R?:: None
Sequence submission?:: None
Computer Readable Form (CRF)?:: No
Title:: SUBSTRATE PROCESSING APPARATUS
AND SEMICONDUCTOR DEVICE
PRODUCING METHOD
Attorney Docket Number:: 2342-0147PUS1
Request for Early Publication?:: No
Request for Non-Publication?:: No
Total Drawing Sheets:: 5
Small Entity?:: No
Petition included?:: No
Secrecy Order in Parent Appl.?:: No

Applicant Information

Applicant Authority Type:: Inventor
Status:: Full Capacity
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Correspondence Information

Correspondence Customer Number:: 02292

Representative Information

Representative Customer Number:: 02292

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP2005/003279	02/28/05

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2004-056363	03/01/04	Yes

Assignee Information

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